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CONFIRMATION NO. 4370

SERIAL NUMBER 10/792,323	FILING DATE 03/03/2004  RULE	CLASS 392	GROUP ART UNIT 3742	ATTORNEY DOCKET NO. AMAT/5191C1/ISM/CORE/MCVD
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## APPLICANTS

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SL

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of 09/953,451 09/14/2001 PAT 6,718,126 D

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

SL

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/24/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 3	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <u>SL</u> Initials				

## ADDRESS

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## TITLE

Apparatus and method for vaporizing solid precursor for CVD or atomic layer deposition

FILING FEE  RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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